

03500.018041.



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
MAKOTO KUBOTA, et al.) : Monica D. Harrison
Application No.: 10/541,495) : Group Art Unit: 2813
371(c) Date: July 7, 2005) :
For: ORGANIC SEMICONDUCTOR)
DEVICE : July 13, 2007

Mail Stop Issue Fee
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Attention Docket Clerk: Code REAS

COMMENTS ON STATEMENT
OF REASONS FOR ALLOWANCE

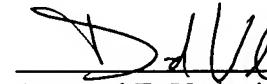
Sir:

Applicants are in receipt of a Notice of Allowance dated June 25, 2007 in the above-referenced application. The issue fee is due on September 25, 2007 and is being paid concurrently herewith.

Applicants respectfully traverse the Reasons for Allowance set forth in the Notice of Allowability on the grounds that independent Claims 1 and 13 do not recite the language "a gate insulating layer on a resin substrate that operates at a low voltage without causing a shortage of electric charges at the interface between the gate insulating layer and the organic semiconductor due to printing or spin coating and through low temperature heat treatment."

Applicants' undersigned attorney may be reached in our Costa Mesa, California, office at (714) 540-8700. All correspondence should continue to be directed to our below-listed address.

Respectfully submitted,



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